IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventors:

H. SADAKATA, et al.

Application No.:

10/624,890

Filed:

July 23, 2003

For:

SEMICONDUCTOR MEMORY DEVICE AND TEST METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents Washington, DC 20231

Dear Sir:

Pursuant to Rules 56 and 99, Applicants hereby call the attention of the Patent Office to the art listed on the attached Form PTO 1449.

Applicants present this art so that the Patent Office may, in the first instance, determine any relevancy thereof to the presently claimed invention, see Beckman Instruments, Inc. v. Chemtronics, Inc., 439 F.2d 1369, 1380, 165 USPQ 355, 364 (5th Cir. 1970). Also see Patent Office Rules 104 and 106. Applicants respectfully request that this art be expressly considered during the prosecution of this application and made of record herein and appear among the "References Cited" on any patent to issue herefrom.

Respectfully submitted,

Date: August 15, 2003

Jame's E. Ledbetter

Registration No. 28,732

JEL/apg

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ATTY. DOCKET NO. SERIAL NO. FORM PTO-1449 U.S. Department of Commerce (Rev. 4/92) Patent and Trademark Office L8462.03107 10/624,890 INFORMATION DISCLOSURE STATEMENT BY APPLICANT **APPLICANT** Hir yuki SADAKATA, et al. (Use several sheets if necessary) NIG 1 5 2003 FILING DATE July 23, 2003 **GROUP** Unassigned **U.S. PATENT DOCUMENTS** FXAMINER IF APPROPRIATE SUBCLASS CLASS DOCUMENT NUMBER DATE NAME 5 4 3 6 9 1 0 07/1995 Takeshima et al. FOREIGN PATENT DOCUMENTS SUBCLASS DATE COUNTRY CLASS TRANSLATION DOCUMENT NUMBER YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) **DATE CONSIDERED EXAMINER** EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.